



PATENT
Docket No.: P108-US

CERTIFICATE OF MAILING BY "FIRST CLASS MAIL" 37 C.F.R. §1.8
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on November 24, 2004 in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.
Douglas C. Limbach
Douglas C. Limbach

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Eldridge et al. Application No.: 09/710,539 Filing Date: November 9, 2000 For: Lithographic Type Microelectronic Spring Structures With Improved Contours	Examiner: Tsukerman, Larisa Z. Group Art Unit: 2839
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CALCULATION OF FEE FOR AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In an Amendment in the above-referenced U. S. patent application filed herewith, a fee for amendment of claims is required as shown below:

AMENDED CLAIMS					
	No.	Previously Paid	Extra	Rate	Fee
Total Claims:	71	minus 70 =	1	\$18	\$18.00
Independent Claims:	3	minus 3	0	\$88	\$0
Multiple dependent claims at \$280.00 each:					\$0
FEE DUE FOR AMENDMENT OF CLAIMS FOR THIS RESPONSE:					\$18.00

- ☐ A Check in the amount of \$_____ is enclosed to cover fees due.
- ☒ Applicants authorize the Director to charge \$18 or any fee deemed due for amendments to the claims to Deposit Account No. 50-0285 (Order No. P108-US).

Respectfully submitted,

Date: November 24, 2004

By: *Douglas C. Limbach*
Douglas C. Limbach
Reg. No. 35,249

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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated August 24, 2004, the period for response to which expires after November 24, 2004, please amend the above-identified application as follows:

11/29/2004 JBALINAN 00000070 500285 09710539

01 FC:1202 18.00 DA